

Subject card

Subject name and code	Physical Methods of Materials Investigation, PG_00059183								
Field of study	Materials Engineering, Materials Engineering, Materials Engineering								
Date of commencement of studies	October 2022		Academic year of realisation of subject		2024/2025				
Education level	first-cycle studies		Subject group		Obligatory subject group in the field of study Subject group related to scientific research in the field of study				
Mode of study	Full-time studies		Mode of delivery			at the university			
Year of study	3		Language of instruction			Polish			
Semester of study	5		ECTS credits			2.0			
Learning profile	general academic profile		Assessment form			exam			
Conducting unit	Institute of Nanotechi	Institute of Nanotechnology and Materials Engineering -> Faculty of Applied Physics and Mathematics						ematics	
Name and surname	Subject supervisor		dr hab. inż. Ag	gnieszka Witko	wska				
of lecturer (lecturers)	Teachers								
Lesson types and methods	Lesson type Lecture		Tutorial	Laboratory	Projec	t	Seminar	SUM	
of instruction	Number of study hours	30.0	0.0	0.0	0.0		0.0	30	
	E-learning hours inclu								
Learning activity and number of study hours	Learning activity	Participation in classes include plan		Participation in consultation hours		Self-study		SUM	
	Number of study hours	<u>'</u> '		1.0		19.0		50	
Subject objectives	The aim of the course is to present the possibilities of modern measurement techniques, along with a description of appropriate measurement systems, methods of analysis of results leading to the determination of structure parameters (macro-, micro- and nanoscopic, as well as at the atomic level) of the studied materials, determination of the chemical composition and physico-chemical and thermal properties.								
Learning outcomes	Course out	Course outcome		Subject outcome			Method of verification		
	K6_K01		The student is aware of the current technological advancement and progression in the development of research and measurement methods, thus she/he understands the need to constantly improve professional and personal competences. Being aware of their own limited possibilities of accessing and operating specialist equipment, the student knows when to refer to experts and how to plan the tasks performed by him/herself or others in these circumstances.			[SK2] Assessment of progress of work			
	K6_W02		On the basis of the acquired knowledge, the student indicates the possibilities of studying the macro- and micro-world, defines the limits of modern cognition and knows how to select research methods due to the type of the tested substance and the analyzed physico-chemical properties. Student knows possibilities of the modern measuring techniques, student presents measuring possibilities related to diffraction and spectroscopy techniques, structure imaging and thermal properties of materials.			[SW1] Assessment of factual knowledge [SW1] Assessment of factual knowledge			

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1. Introduction - physical methods of material investigation and experiment planning. 2. Diffraction methods - theoretical basis: a) X-ray diffraction; - X-ray sources (X-ray tube, synchrotron, synchrotron radiation) - detectors of ionizing radiation - structural X-ray diffraction b) Neutron diffraction; - neutron beam sources - neutron detection - ND vs XRD c) Electron diffraction - electron beam sources and detection - ED vs XRD - LEED, RHEED 3. Spectroscopic methods - introduction and theoretical basis: a) Absorption, emission, photoemission and scattering spectroscopy b) Molecular spectroscopy c) Electron spectroscopy 4. Structure imaging methods a) Electron microscopy b) Scanning probe microscopy c) Confocal microscopy d) Spectromicroscopy 5. Thermal analysis (DTA, DSC, TGA). 6. Adsorption methods: physical adsorption vs chemisorption, study of structural heterogeneity and pore size distribution.						
The basics knowledge of material	The basics knowledge of material engineering, physics, crystallography and general chemistry					
Subject passing criteria	Passing threshold	Percentage of the final grade				
Active participation in lectures	0.0%	15.0%				
Writting exam	50.0%	85.0%				
[1] A. Siese, Metody doswiadczalne itzyri dała stalego, WN (in Polish) [2] J.Przedmojski, Rentgenowskie metody badawcze w Inżynierii Materiałowej, WNT (in Polish) [3] Z. Kęcki, Podstawy spektroskopii molekularnej, PWN, Warszaw Polish) [4] A. Kisiel, Synchrotron jako narzędzie: zastosowanie PS w spektroskopii ciała stałego, SRNS 5(3) (2006) (in Polish) Supplementary literature [5] Ch. Kittel, P. McEuen, Introduction to solid state physics (9th Ec New Jersey: Wiley [6] J.M. Hollas, Modern Spectroscopy, John Wiley & Sons, Ltd. [7] P. Willmott, An Introduction to Synchrotron Radiation: Techniquiand Applications, John Wiley & Sons, Ltd. [8] A. Barbacki (red.), Mikroskopia elektronowa, Wyd. Politechniki Poznańskiej (in Polish) [9] P. Atkins, J.de Paula, Chemia fizyczna, Rozdz.16 Spektroskopia widma rotacyjne i oscylacyjne; Rozdz. 17 Spektroskopia 2: przejścielektronowe, PWN (in Polish)						
eResources addresses	Adresy na platformie eNauczanie:					
1. Diffraction methods: physical basis, types and applications. 2. X-ray tube: its structure, principle of operation and properties of X-ray obtained using this source. 3. What is a synchrotron and how does it work? Describe the basic properties of synchrotron radiation. 4. X-ray and electron diffraction - indicate similarities and differences. 5. Neutron and electron diffraction - indicate similarities and differences. 6. Name and briefly describe two sources of neutron beams used in neutronography. 7. Silicon crystallizes in a simple cubic system. A neutron diffraction experiment with a 10-meter detector and angle = 45° reveals that the neutrons reflected from the family of planes (111) have a time of flight of 11200 microseconds. Find the lattice constant of a silicon unit cell? 8. List and briefly characterize detectors of ionizing radiation. 9. What is a spectrum? Give and discuss the parameters that characterize the spectral line. 10. Explain the terms transmittance, absorbance and absorption coefficient. Give the relationship between them. 11. Present the idea of the Raman phenomenon and discuss the shape of the Raman spectrum. 12. Explain why the XPS technique is a "surface sensitive" technique. 13. AFM microscope: describe operating modes and its applications. 14. Electron microscopy - list the types of electron microscopes, compare them and determine their applications. 15. State what thermal analysis is, its types and possible applications. 16. DSC technique (differential scanning calorimetry) - state what kind of thermal properties of materials can be determined using this technique and how. 17. Discuss the differences between physical and chemical adsorption. 18. Select and provide two of the research techniques you have learned, thanks to which you can determine/ estimate the average size of nanoparticles. Briefly describe how we use these techniques in terms of the mentioned properties of the tested material.						
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